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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
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Akira Miura

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38834

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01/02/2009

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP
1250 CONNECTICUT AVENUE, NW
SUITE 700
WASHINGTON, DC 20036

EXAMINER

REAMES, MATTHEW L

ART UNIT

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2893

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PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Office Action Summary	Application No. 10/767,167	Applicant(s) MIURA ET AL.	
	Examiner Matthew Reames	Art Unit 2893	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 9/26/2008.
- 2a) ☒ This action is **FINAL**. 2b) ☐ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1,2 and 4-14 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☐ Claim(s) 1,2 and 4-14 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
 2. ☐ Certified copies of the priority documents have been received in Application No. _____.
 3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|--|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892) | 4) <input type="checkbox"/> Interview Summary (PTO-413) |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | Paper No(s)/Mail Date. _____ |
| 3) <input checked="" type="checkbox"/> Information Disclosure Statement(s) (PTO/SB/08) | 5) <input type="checkbox"/> Notice of Informal Patent Application |
| Paper No(s)/Mail Date <u>7/25/2008</u> . | 6) <input type="checkbox"/> Other: _____ |

DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

1. Claims 1-2, 5-8, 11-13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Mori (5,247,223).

a. As to claim 1-2, and 11 and 11, Mori teaches a fine vacuum tube being used as an interference system (fig. 3) specifically the Aharonov-Bohm effect which uses the quantum effect of ballistic electrons. Mori further teaches a magnetic field in communication with the device (see column 6).

Mori does not explicitly teach the use of the device in an integrated circuit.

However integrated circuit with transistors and other solid state elements was well known in the art.

Therefore it would have been obvious to one of ordinary skill in the art at the time of the invention to have used the device of Mori in an integrated circuit.

One would have been so motivated in order to have formed an integrated circuit with a transistor capable of operating at high speed at room temperature (see e.g. column 5).

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b. As to claim 5, integrated optical devices with transistors an optical devices was well known in the art.

Therefore it would have been obvious to one of ordinary skill in the art at the time of the invention to integrate the device of Mori into a high speed optical network.

One would have been so motivated for the high speed attainable by the device of Mori increasing overall device performance.

c. As to claim 6, magnetic and electric sensing devices were well known in the art and further known to have transistors and other electronic devices.

Therefore it would have been obvious to one of ordinary skill in the art at the time of the invention to integrate the device of Mori magnetic/electric sensor.

One would have been so motivated for the high speed attainable by the device of Mori increasing overall device performance.

d. As to claims 7-8, Mori teaches a thermionic cathode maybe used (see last sentence of column 6).

Mori does not explicitly teach a carbon nanotube.

However these were well known in the art for there use in electron emitting devices.

Therefore it would have been obvious to one of ordinary skill in the art at the time of the invention to have used a carbon nanotube in conjunction or in place of the tip of Mori.

One would have been so motivated in order to have formed a sharper tip for the device increasing device functionality, or in order to simplify manufacturing since etching would not be required.

e. As to claim 12 and 13, Mori does not explicitly teach how the magnetic field is generated. However coils and current lines were widely known conventional method of creating magnetic fields.

Therefore it would have been obvious to one of ordinary skill in the art at the time of the invention to have made the magnetic field generating unit as a coil or two current lines.

One would have been so motivated since it would reduce cost and enable the device to be integrated with existing technology.

2. Claims 1-2, 4, and 9-13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Okada (5,003,360) in view of Mori.

a. Okada teaches using a semiconductor device using the Aharonov-Bohm effect, measuring the phase difference of a electron as it travels through a slit (see e.g. fig. 1 and fig. 4), can be used to form digital to analog converters by forming a plurality of such devices (see e.g. fig. 1 and description, fig. 4 and description and fig. 9 and description). Okada further teaches a semiconductor device. Okada further teaches the device is made from semiconductor material and is not a vacuum tube. Okada further teaches a magnetic field in communication with the device (see e.g. column 3).

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Mori teaches the fine vacuum tube used as an interference device (see e.g. fig. 3). Mori further teaches the transistor of Okada fig. 1 was known (see e.g. fig. 1 of Mori). Further Mori teaches the devices of Okada using a semiconductor material must be cooled to low temperature in order to operate (see e.g. background).

Therefore it would have been obvious to one of ordinary skill in the art at the time of the invention to have formed the A/D converter of Okada fig. 9 from the fine vacuum tubes devices of Mori.

One would have been so motivated in order to operate the device at room temperatures.

b. As to claims 9-10, it is unclear what a Mach-Zehnder interferometer for an electron is since the term is used for optical systems.

However Okada teaches the interferometer as claimed/suggested (see e.g. figs. 9). Therefore the Okada/Mori device will be understood to be a Mach Zehnder interferometer.

c. As to claims 12 and 13, Okada does not explicitly teach how the magnetic field is generated. However coils and current lines were widely known conventional methods of creating magnetic fields.

Therefore it would have been obvious to one of ordinary skill in the art at the time of the invention to have made the magnetic field generating unit as a coil or two current lines.

One would have been so motivated since it would reduce cost and enable the device to be integrated with existing technology.

Allowable Subject Matter

3. Claim 14 is allowed.

The following is an examiner's statement of reasons for allowance: Prior art fails to teach a quartz window in communication with said fine (nano) vacuum tube, a photoelectric conversion element in communication with said quartz window in conjunction with other elements of claim 14.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Response to Arguments

4. Applicant's arguments with respect to claim 1 have been considered but are moot in view of the new ground(s) of rejection.

Conclusion

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Fujii (5,157,467) teaches optically gating an Aharonov-Bohm device but does not teach a quartz window.

6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP

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§ 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Matthew Reames whose telephone number is (571) 272-2408. The examiner can normally be reached on M-Th 6:00 am-4:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Davienne Monbleau can be reached on (571)272-1945. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Jerome Jackson Jr./
Primary Examiner, Art Unit 2815

/MLR/